



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

LIU et al.

Serial No.: 09/467,675

Filed: Dec. 21, 1999

For: Structure For ESD Protection With Single
Crystal Silicon Sided Junction

Examiner: NADAV, O

Art Unit: 2811

Docket No.: 252103-4540

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I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail, postage
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Signature - Hui Chin Barnhill

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RESPONSE TO OFFICE ACTION

Assistant Commissioner of Patents and Trademarks
Washington, DC 20231

Sir:

The Office Action mailed Aug. 13, 2001 (Paper No. 9), has been carefully considered. In
response thereto, please consider the following remarks.

REMARKS

Present Status of the Application

The Office Action rejected all presently-pending claims 1-16 and 18-21. Specifically, the
Office Action rejected claims 1-16 and 18-21 under 35 U.S.C. 103(a), as being unpatentable over
Yamaguchi et al. (U.S. Patent 6,118,154) in view of Hu et al. (U.S. Patent 6,121,077), Erdeljac et

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Response
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